

Notice of References Cited

Application/Control No.

10/695,396

Applicant(s)/Patent Under
Reexamination
KIM ET AL.

Examiner

DAVID Y. CHUNG

Art Unit

2871

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,285,301	02-1994	Shirahashi et al.	349/143
*	B	US-6,005,542	12-1999	Yoon, Sang Young	345/92
	C	US-			
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	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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NON-PATENT DOCUMENTS

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